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** CONTINUING DATA *****

This application is a CON of 09/739,905 12/20/2000 PAT 6,607,986

** FOREIGN APPLICATIONS *****

JAPAN 11-372006 12/28/1999

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Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after	STATE OR COUNTRY	SHEETS DRAWING	TOTAL CLAIMS	INDEPENDENT CLAIMS
Verified and Acknowledged	Examiner's Signature <i>M. A. [Signature]</i> Initials <i>F.H.</i>	JAPAN	8	20	3

ADDRESS

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TITLE

Dry etching method and semiconductor device manufacturing method

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